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PATENT
Attorney Docket No.: 3521.165

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of)
) Group Art Unit: 2834
 MARK E. WILLIAMS)
) Examiner:
 Serial No.: 10/023,144)
)
 Filed: December 17, 2001)

For: MAGNETIC LEVITATION STAGE APPARATUS AND METHOD

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I hereby certify that this paper, and the listed enclosures, and fee is being deposited with the United States Postal Service "Express Mail Post Office to Addressee" service under 37 CFR 1.10 on the date indicated below and is addressed to Box Missing Parts, U. S. Patent and Trademark Office, P.O. Box 2327, Arlington, VA 22202 with the Express Mail Label No. EL865008209US on April 11, 2002.

Alston L. Jones, Attorney for Applicant

**TRANSMITTAL OF INFORMATION DISCLOSURE STATEMENT WITHIN THREE
MONTHS OF FILING OR BEFORE MAILING OF FIRST OFFICE ACTION
(37 CFR 1.97(b))**

The information disclosure statement submitted herewith is being filed before the mailing date of a first Office action on the merits. 37 CFR 1.97(b).

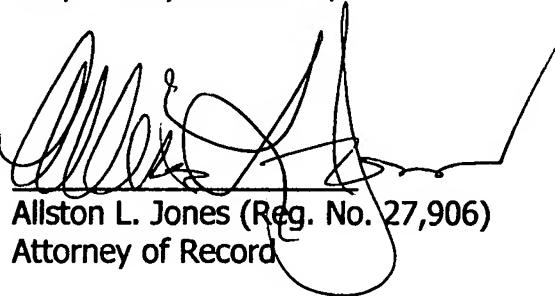
The citation listed on the attached PTO 1449, along with the enclosed copies of the references, provides the background and may be material to the examination of the above-identified application and is, therefore, submitted in compliance with the duty of disclosure in 37 C.F.R. 1.56, 1.97 and 1.98.

The Examiner is requested to make the citation of official record in this application.

This Information Disclosure Statement under 37 C.F.R. 1.56 and 1.97 is not to be construed as a representation that a search has been made, that additional information material to the examination of this application does not exist, or that any one or more of these citations constitutes prior art.

If fees are required with the filing of these documents, the Commissioner is authorized to charge such fees to Deposit Account No. 16-1331.

Respectfully submitted,



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Date: April 11, 2002

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FOR PTO-1449 (Modified)		ATTY. DOCKET NO.	SERIAL NO.
DISCLOSURE OF PATENTS AND PUBLICATIONS FOR APPLICANT'S INFORMATION DISCLOSURE STATEMENT <small>(Use several sheets if necessary)</small>		3521.165	10/023,144
		APPLICANT MARK E. WILLIAMS	
		FILING DATE December 17, 2001	GROUP 2834

REFERENTIUM DESIGNATION

U.S. PATENT DOCUMENTS

FOREIGN PATENT DOCUMENTS

OTHER

ART (Including Author, Title, Date, Pertinent Pages, Etc.)

	E	M. E. Williams et al., <i>Magnetic Levitation Scanning Stages for Extreme Ultraviolet Lithography</i> , ASPE 14 th annual meeting, Monterey CA., November 1999
	F	John B. Wronosky, et al., <i>Wafer and Reticle Positioning System for the Extreme Ultraviolet Lithography Engineering Test Stand</i> , SPIE, February 2000

EXAMINER

DATE CONSIDERED

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.